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PATENT
790001-2042IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Naofumi NAKAMURA et al.
U.S. Serial No. : 10/752,642
Filing Date : January 7, 2004
For : **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME**
Examiner: : Jesse A. Fenty
Group Art Unit : 2815

745 Fifth Avenue
New York, New York 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 9, 2005.

Angela M. Collison, Reg. No. 51,107
(Name of Applicant, Assignee or Registered Representative)

Angela M. Collison
Signature

February 9, 2005

Date of Signature

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed January 12, 2005, setting a thirty-day period for reply and asserting a restriction requirement, Applicants elect Group I (claims 1-14), without traverse, for further prosecution in this application.

Applicants reserve the right to file divisional applications to non-elected subject matter.

If any issues remain, or if the Examiner has any further suggestions, he/she is invited to call the undersigned at the telephone number provided below.

The Examiner is hereby authorized to charge any insufficient fees or credit any overpayment associated with the above-identified application to Deposit Account No. 50-0320.

The Examiner's consideration of this matter is gratefully acknowledged.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants

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